

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/735,154	KO, DAVID (TSO-CHIN)	
Examiner	Art Unit	
Edwin A. León	2833	

SEARCHED					
Class	Subclass	Date	Examiner		
439	607-610	4/8/2005	EAL		
439	660	4/8/2005	EAL		
439	492-495	4/8/2005	EAL		
439	79	4/8/2005	EAL		
439	571-573	4/8/2005	EAL		
439	629	4/8/2005	EAL		
439	108	4/8/2005	EAL		
439	901	4/8/2005	EAL		
Update	search	9/23/2005	EAL		
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INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
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